

Sergey Bogdanov

List of Publications by Year in descending order

Source: <https://exaly.com/author-pdf/1479403/publications.pdf>

Version: 2024-02-01

26
papers

296
citations

933447

10
h-index

888059

17
g-index

26
all docs

26
docs citations

26
times ranked

323
citing authors

#	ARTICLE	IF	CITATIONS
1	Investigation of High-Density Nitrogen Vacancy Center Ensembles Created in Electron-Irradiated and Vacuum-Annealed Delta-Doped Layers. <i>Physica Status Solidi - Rapid Research Letters</i> , 2021, 15, 2000550.	2.4	6
2	Study of Undoped Nanocrystalline Diamond Films Grown by Microwave Plasma-Assisted Chemical Vapor Deposition. <i>Semiconductors</i> , 2021, 55, 66-75.	0.5	2
3	Investigation of NV centers charge states in CVD diamond layers doped by nitrogen and phosphorous. <i>Journal of Luminescence</i> , 2021, 239, 118404.	3.1	5
4	Investigation of homoepitaxial growth by microwave plasma CVD providing high growth rate and high quality of diamond simultaneously. <i>Materials Today Communications</i> , 2020, 22, 100816.	1.9	15
5	The Use of Pulsed Laser Annealing to Form Ohmic Mo/Ti Contacts to Diamond. <i>Technical Physics Letters</i> , 2020, 46, 551-555.	0.7	2
6	Formation of Multilayered Nanostructures of NV Sites in Single-Crystal CVD Diamond. <i>Technical Physics Letters</i> , 2020, 46, 641-645.	0.7	1
7	Optical investigation of as-grown NV centers in heavily nitrogen doped delta layers in CVD diamond. <i>Materials Today Communications</i> , 2020, 24, 101019.	1.9	4
8	On investigation as grown NV centers in delta doped layers in diamond. <i>AIP Conference Proceedings</i> , 2020, , .	0.4	1
9	Creation of Localized Ensembles of NV Centers in a Diamond Grown in a Microwave CVD Reactor and Study of Their Properties. <i>Radiophysics and Quantum Electronics</i> , 2020, 63, 530.	0.5	0
10	Contraction of Microwave Discharge in the Reactor for Chemical Vapor Deposition of Diamond. <i>Technical Physics Letters</i> , 2019, 45, 89-92.	0.7	10
11	Visible and near-infrared photodetector on chemically vapor deposited diamond. <i>Diamond and Related Materials</i> , 2019, 97, 107444.	3.9	2
12	Ohmic Contacts to CVD Diamond with Boron-Doped Delta Layers. <i>Semiconductors</i> , 2019, 53, 1348-1352.	0.5	0
13	Misorientation Angle Dependence of Boron Incorporation Into CVD Diamond Delta Layers. <i>Physica Status Solidi (B): Basic Research</i> , 2019, 256, 1800606.	1.5	3
14	Creation of Localized NV Center Ensembles in CVD Diamond by Electron Beam Irradiation. <i>Technical Physics Letters</i> , 2019, 45, 281-284.	0.7	4
15	Study of microwave discharge at high power density conditions in diamond chemical vapor deposition reactor by optical emission spectroscopy. <i>Diamond and Related Materials</i> , 2019, 97, 107407.	3.9	17
16	Emission properties of undoped and boron-doped nanocrystalline diamond films coated silicon carbide field emitter arrays. <i>Journal of Vacuum Science and Technology B: Nanotechnology and Microelectronics</i> , 2018, 36, 021204.	1.2	5
17	Investigation of boron incorporation in delta doped diamond layers by secondary ion mass spectrometry. <i>Thin Solid Films</i> , 2018, 653, 215-222.	1.8	14
18	Synthesis of thick and high-quality homoepitaxial diamond with high boron doping level: Oxygen effect. <i>Diamond and Related Materials</i> , 2017, 74, 59-64.	3.9	30

#	ARTICLE	IF	CITATIONS
19	Nanometric diamond delta doping with boron. Physica Status Solidi - Rapid Research Letters, 2017, 11, 1600329.	2.4	27
20	Influence of CVD diamond growth conditions on nitrogen incorporation. Diamond and Related Materials, 2017, 72, 1-6.	3.9	47
21	Bragg superlattices formed in growing chemically vapor deposited diamond. Journal of Applied Physics, 2016, 120, 224901.	2.5	3
22	Method of power density determination in microwave discharge, sustained in hydrogen-methane gas mixture. Diamond and Related Materials, 2016, 66, 177-182.	3.9	18
23	Single-crystal GaN/AlN layers on CVD diamond. Technical Physics Letters, 2015, 41, 954-956.	0.7	0
24	Temperature admittance spectroscopy of boron doped chemical vapor deposition diamond. Journal of Applied Physics, 2015, 118, .	2.5	17
25	Experimental study of hydrogen plasma etching of (100) single crystal diamond in a MPACVD reactor. Materials Letters, 2015, 151, 115-118.	2.6	38
26	Growth-rate Enhancement of High-quality, Low-loss CVD-produced Diamond Disks Grown for Microwave Windows Application. Chemical Vapor Deposition, 2014, 20, 32-38.	1.3	25